

PTO/SB/08a (07-05) (TMB 07/2005)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

SHEET 2 of 2

Application Number	10/525,763
Filing Date	August 25, 2005
First Named Inventor	Janusz Murakowski
Art Unit	1786 1795
Examiner Name	Christopher G. Young
Attorney Docket No.	UOD-211US

Examiner Initials*	Cite No.¹	Include name of the author (In CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
/CYI/	4	CHENG, CHUAN C. et al., "New Fabrication Techniques for High Quality Photonic Crystals," J. Vac. Sci. Technology B., 15(6), November/December 1997, pp. 2764-2767	<input type="checkbox"/>
/CYI/	5	SCHNEIDER, GARRETT J. et al., "Combination Lithography for Photonic-Crystal Circuits," J. Vac. Sci. Technology B., 22(1), January/February 2004, pp. 146-151	<input type="checkbox"/>
/CYI/	6	MURAKOWSKI, JANUSZ et al., "Combination Lithography for Photonic Crystal Circuits," Proceedings of SPIE, 5000, July 2003, pp 1-8	<input type="checkbox"/>
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Examiner Signature	/Christopher Young/ (01/21/2008)		Date Considered 01/21/2008

***Applicant's unique citation designation number (optional).**

²Applicant is to place a check mark here if English language translation is attached.

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